



Deposit Al on quartz wafer



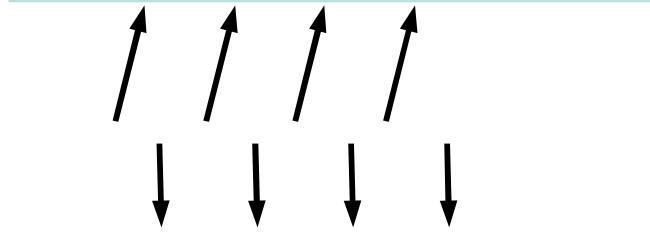
Pattern Al



Deposit SU-8



Angled self-aligned exposure



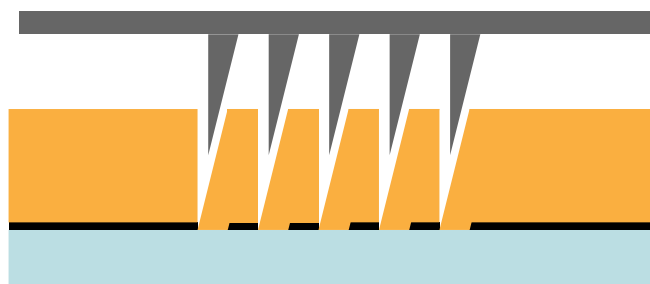
Align mask and expose



Develop SU-8



Cast and spin PDMS



Peel out adhesive and backing



Quartz Wafer



Exposed SU-8



PDMS



Unexposed SU-8